

Attorney's Docket No.: 42P17283



Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

McSwiney et al.

Application No: 10/750,062

Filed: December 30, 2003

For: METHOD AND APPARATUS FOR
LOW TEMPERATURE SILICON NITRIDE
DEPOSITION

Examiner: Turocy, David P.

Art Unit: 1792

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE TO OFFICE ACTION

Dear Sir:

In response to the Office Action dated November 1, 2007, Applicants respectfully request that the above-identified application be amended as follows and that the following remarks be considered:

FIRST-CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia, 22313-1450, on:

February 25, 2008

Date of Deposit

Carrie Boccaccini

Name of Person Mailing Correspondence

Signature

Date

McSwiney et al.
Serial No.: 10/750,062

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